• High speed dual arm robot
• Non-contact wafer center and flat/notch find
• Multiple wafer size recognition from 2” to 300mm
• Up to 4 cassette platforms
• SECS II/GEM/HSMS
• User customizable screens
• Multi-level password protection
• Recipes created on or offline
• Smallest Footprint - 24” x 40”

“Essential Sorting and Wafer Tracking System”

• Virtual Tweezer mode allows operator to easily move wafers between cassettes or slots
• MicroSORT scripting with unlimited recipe capability.